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	Application Number		10008439	
INFORMATION DIGGLOCULE	Filing Date		2001-12-06	
	First Named Inventor Ploure		de Jr., et al.	
	Art Unit		2621	
(Not for Submission under or of K 1.00)	Examiner Name	Choi,	Michael P.	
	Attorney Docket Number	∍r	A-7314	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT ( Not for submission under 37 CFR 1.99)	First Named Inventor Art Unit Examiner Name	Choi,	de Jr., et al. 2621 Michael P.	

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